

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
H. Fujimura et al.

Docket: 2060.3

Serial No. :

Filed:

For: DIAMOND-COATED SILICON AND ELECTRODE

**PRELIMINARY AMENDMENT**

Mail Stop PCT  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to the examination of the above-identified application, please  
amend the application as follows:

**In the Claims:**

Please amend claims as follows:

1. (original) A diamond-coated silicon comprising a silicon substrate having a thickness of 500  $\mu\text{m}$  or less coated at least partially with electrically conductive diamond.
2. (original) An electrode, comprising an electrically conductive support substrate and the diamond-coated silicon according to claim 1.